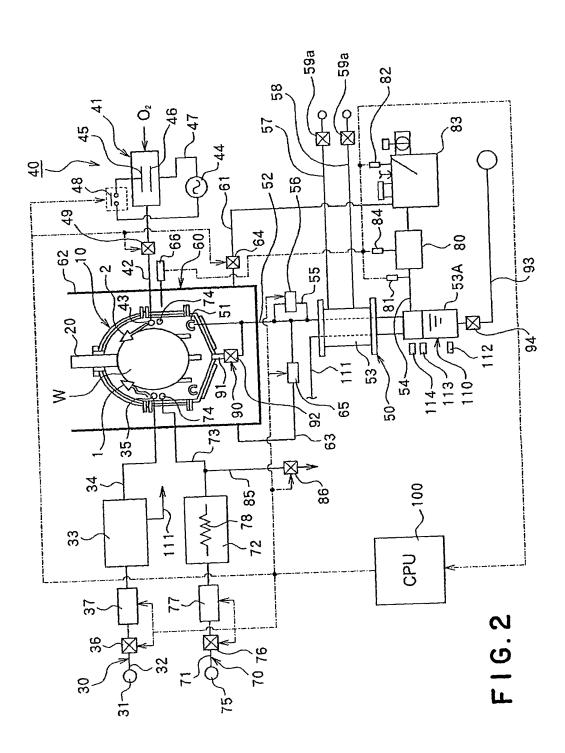
Title: Substrate Processing Method and Substrate.. Inventor: Takayuki TOSHIMA

Inventor: Takayuki TOSHIMA Application No.: Not yet assigned Docket No.: 199372003500

FIG.IA PRIOR ART	W RP1
FIG.IB PRIOR ART	W-W-MAN
FIG.IC PRIOR ART	RP1 - 0X1 W
FIG.ID PRIOR ART	W OX1
FIG.IE PRIOR ART	0X1 0X2 W
FIG.IF PRIOR ART	OX1 OX2  W——RP2
FIG.IG PRIOR ART	OX1 OX2  W——RP2
FIG.IH PRIOR ART	OX1 OX2

Title: Substrate Processing Method and Substrate.. Inventor: Takayuki TOSHIMA Application No.: Not yet assigned Docket No.: 199372003500

2/10



Title: Substrate Processing Method and Substrate.. Inventor: Takayuki TOSHIMA Application No.: Not yet assigned Docket No.: 199372003500

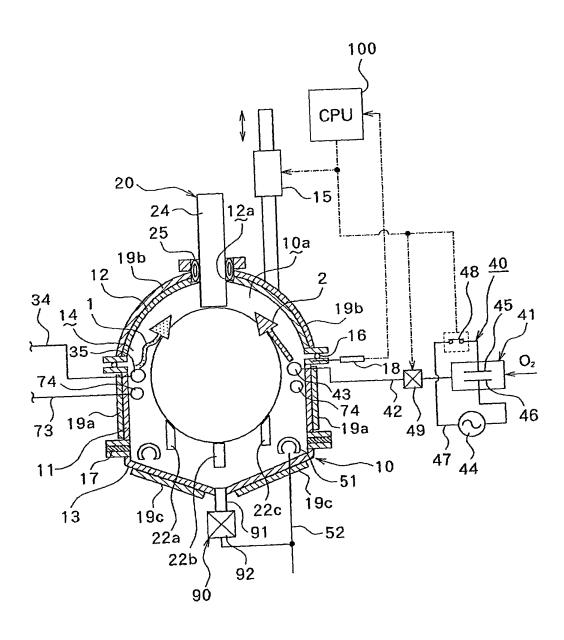


FIG. 3

Title: Substrate Processing Method and Substrate.. Inventor: Takayuki TOSHIMA Application No.: Not yet assigned Docket No.: 199372003500

4/10

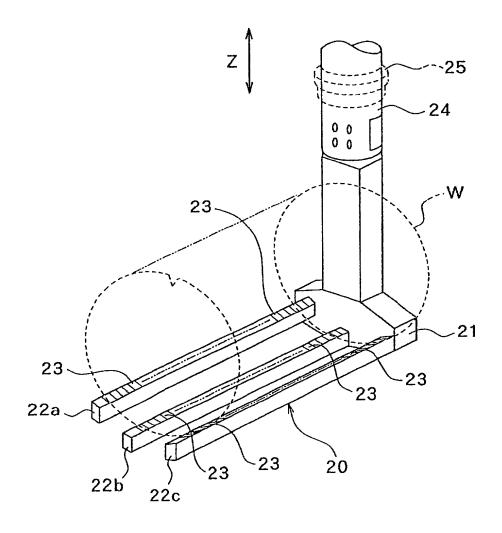


FIG. 4

Title: Substrate Processing Method and Substrate.. Inventor: Takayuki TOSHIMA

5/10

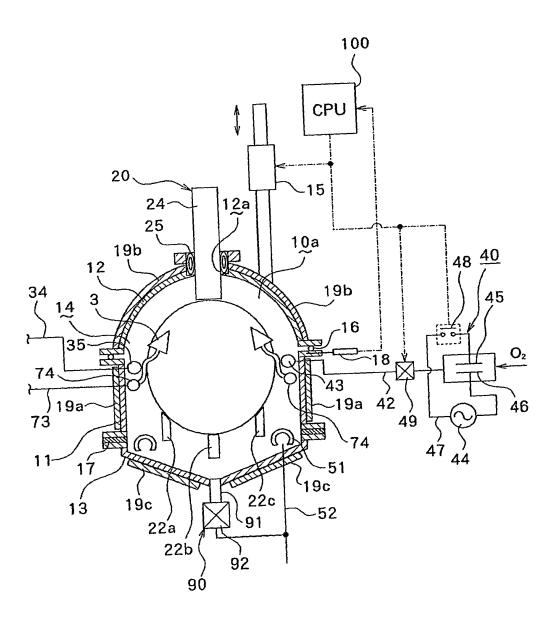


FIG. 5

Title: Substrate Processing Method and Substrate..

6/10

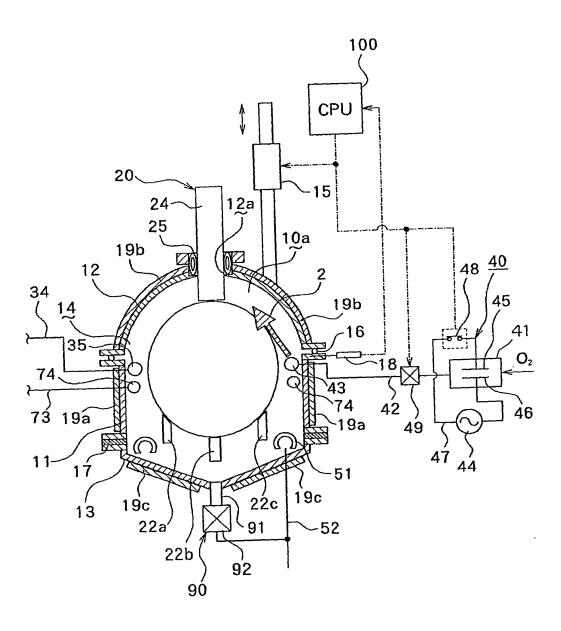


FIG. 6

Title: Substrate Processing Method and Substrate.. Inventor: Takayuki TOSHIMA

7/10

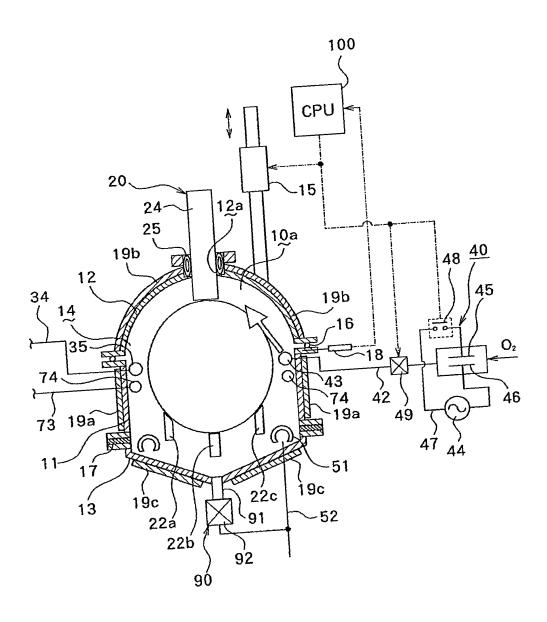


FIG.7

Title: Substrate Processing Method and Substrate..

8/10

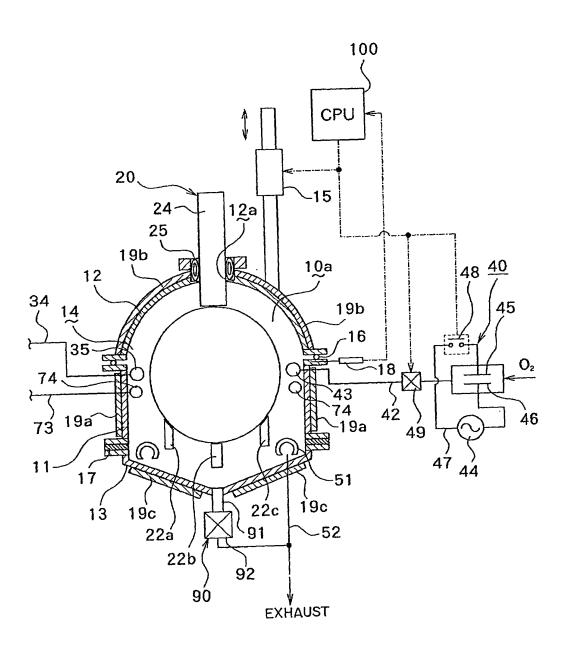


FIG. 8

Title: Substrate Processing Method and Substrate..

Inventor: Takayuki TOSHIMA Application No.: Not yet assigned Docket No.: 199372003500

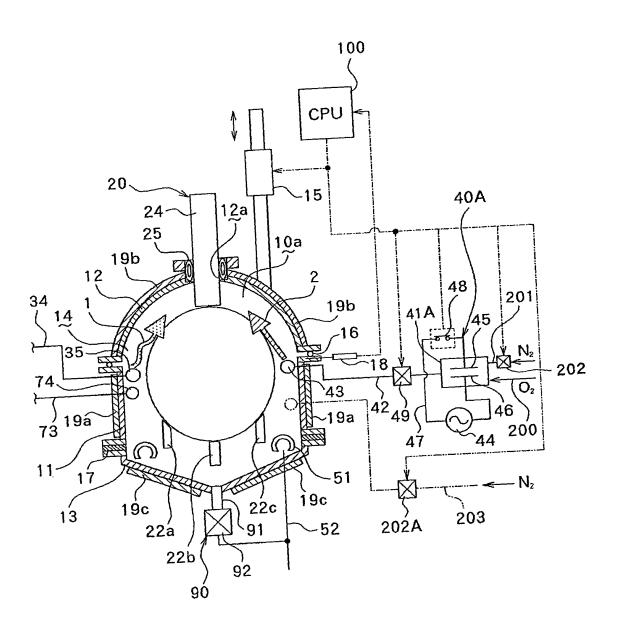


FIG. 9

Title: Substrate Processing Method and Substrate.. Inventor: Takayuki TOSHIMA Application No.: Not yet assigned Docket No.: 199372003500

